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PAGE 1/7 * RCVD AT 6/27/2005 11:45:44 AM [Eastern Daylight Time] * SVR:USPTO-EFAX-1/0 * DNIS:8729306 * CSID:5109233360 * DURATION (mm-ss):01-18

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Reference to:
Application No.: 10/723,046
Filing date: 11/26/2003
Act unit: 2811
Applicant: Hui Peng
Title: Texture of Substrate and a Method for Minimizing Effects of Lattice Mismatch
Examiner/Art Unit: Shouxiang Huo/2811

Fremont, CA, June 27, 2005

AMENDMENT A

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This letter responds to the Office Action Summary dated May 24, 2005 and mailed to applicant on 5/31/2005. Please amend the above patent application as the following.

TITLE: replace with following new title:

"Texture for Localizing and Minimizing Effects of Lattice Constants Mismatch"

SPECIFICATION: There is no amendment to the specification.

CLAIMS: Amendment to the claims of the above patent application begin on page 2 of this amendment.

DRAWINGS: There is no amendment to the drawings.

REMARKS: Remarks begin on page 5 of this amendment.